SIMTEK6349

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of Chihiro Araki

Patent No. 6,809,532

Issued: October 26, 2004

App. No.: 10/063,869

Filed: May 21, 2002

Conf. No : 2434

Title:

INSPECTION METHOD AND

INSPECTION APPARATUS FOR SEMICONDUCTOR CIRCUIT

Examiner: T. Nguven

Art Unit: 2829

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

STATUS LETTER

Dear Sir-

A request for a Certificate Of Correction was filed regarding this patent on February 28, 2005, but to date no action has been taken on this request even though it was filed over two years ago. Please advise when this will be acted upon.

Respectfully submitted:

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